

New Strategy for Black Phosphorus Crystal Growth through Ternary Clathrate

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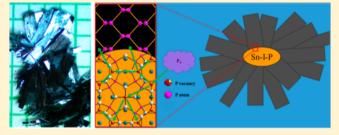
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ABSTRACT: We are reporting a new synthetic strategy to grow large-sized black phosphorus (Black-P) crystals through a ternary clathrate Sn₂₄P_{22-x}I₈, under lower synthetic temperature and pressure. The Black-P crystals are found grown in situ at the site where the solid clathrate originally resides, which suggests chemical vapor mineralizer does not play a critical role for the Black-P formation. More detailed systematical studies have indicated the P vacancies in the framework of the ternary clathrate Sn₂₄P_{22-x}I₈ are important for the subsequent Black-P from phosphorus vapors, and a



likely vapor—solid—solid model is responsible for the Black-P crystal growth. The obtained room temperature mobility μ is ~350 cm²/V·s from Hall measurements at mechanically cleaved flakes, where noticeable microcracks are visible. The obtained high mobility value further suggests the high quality of the Black-P crystals synthesized through this route.

1. INTRODUCTION

Black phosphorus (Black-P) and its monolayer counterpart, phosphorene, emerge as a promising candidate of twodimensional (2D) materials owing to their comprehensive outstanding properties, especially the range of their band gaps and potentially high carrier mobilities. $^{1-4}$ Therefore, they attract tremendous immediate interests from condensed matter physicists, chemists, semiconductor device engineers, and material scientists. Black-P was first discovered more than one hundred years ago⁵ and is the most stable allotrope of phosphorus (P) with a puckered layer structure. The monolayer Black-P includes two atomic layers with two different kinds of P-P bonding patterns. The top view of Black-P along the z direction shows a hexagonal structure with bond angles of 96.3° and 102.1°, respectively. Recent theoretical studies have predicted that monolayer Black-P (phosphorene) can have an extremely high hole mobility $(10\,000 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1})$.¹ Depending on the thickness, the band gap of Black-P can cover 0.3-2.0 eV,² which bridges the zero band gap of graphene and the relatively large band gap of many transition metal dichalcogenides (TMDs). The band gap of Black-P covers the near and mid-infrared spectrum, thus making it an appealing candidate for near- and mid-infrared optoelectronics.^{6,7} Moreover, the mobility/on-off ratio combination for Black-P falls into a region that could not be easily covered by graphene or TMDs.

Black-P was historically synthesized under high pressure (~1.2 GPa) conditions from white phosphorus (White-P) and red phosphorus (Red-P).⁵ It was also reported that Black-P was prepared from a solution of White-P in mercury⁸ or bismuthflux.⁸⁻¹⁰ Since readily stable Red-P does not dissolve in the flux, and the lack of high purity White-P due to its chemical activity, some sophisticated chemical treatment and apparatus are normally adopted for the synthesis, yet still yield deformed crystals, not to mention the potential high cost and high toxicity associated with the flux.^{10,11} It was not until very recently that Black-P was reported to be synthesized at a lower pressure and much cleaner controlled atmosphere through mineralizer-assisted vapor transport reaction.¹² The mineralization additive reported initially was Au/Sn/SnI4,12 and then simplified to Sn/SnI4.13 Because the reaction temperature (~600 °C) is much higher than the sublimation temperature of SnI_4 (~200 °C), it is further simplified to use Sn/I_2^{14} to grow Black-P ribbons with a muffle furnace (with less temperature

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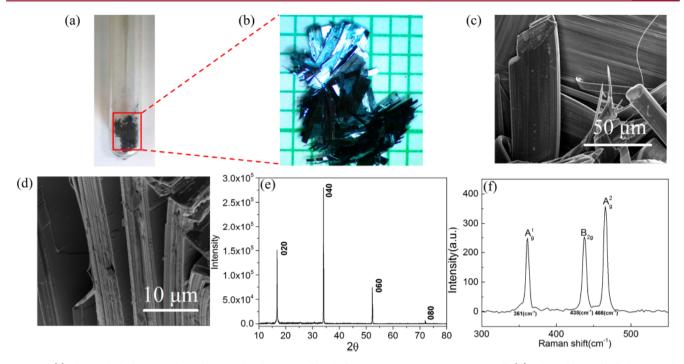


Figure 1. (a) Photo of Black-P crystals in the ampule tube grown directly from ternary $Sn_{24}P_{22-x}I_8$ compound; (b) enlarged view of Black-P crystals on the mm scale. (c) Top view of SEM image of selected crystals showing ribbon-sharp morphology; (d) side view of SEM image showing the layered nature of the grown crystal. (e) XRD patterns, and (e) Raman spectrum of the grown Black-P crystals.

gradient and large reaction space). Zhao et al.¹⁴ further extended their studies to investigate the growth mechanism and proposed some speculated growth models based on their results.

However, many questions regarding to Black-P crystal growth remain. For example, what is the exact role of these mineralization additives to promote the formation of Black-P and their specific mechanism at different temperature stages? What exactly is the formation temperature range and growth model for Black-P? Is it a slow growing process from the highest temperature (>600 °C) down to the lowest temperature (~200 °C), similar to the crystallization and crystal growth in the flux? Or it is a rather rapid process that occurs at a much narrower temperature range? Different species such as Sn, I₂, SnI₂, SnI₄, and Au have been used in the past as necessary chemicals assisting the growth of Black-P. However, the exact functions of these chemicals are not well understood yet. At the reported highest temperature (650 or 590 °C), the most thermodynamically stable species is the SnI₂. Therefore, those additives such as Sn, I2, or SnI4 will probably either react with each other or decompose to form $SnI_2(g)$: $Sn + I_2 \xrightarrow{>100 \text{ °C}}$ SnI_2 ; $SnI_4 \xrightarrow{>340 \ ^{\circ}C} SnI_2 + I_2$. The gaseous SnI_2 will react with P_4 vapor (sublimed from Red-P) upon cooling, which assists the formation of Black-P. Previous studies¹⁴ have ambiguously speculated that some gaseous ternary P-Sn-I compound formed before the formation of Black-P ribbons is crucial for the nucleation and continuous growth of the Black-P crystals. However, the exact composition of the solid state material prior to the formation of Black-P, and its role to promote the reaction, remain unknown. Under this motivation, we have carried out systematic studies to investigate the exact growth model of Black-P. We found out that the ternary type-I inverse clathrate Sn₂₄P_{22-x}I₈ is the sole ternary phase of Sn, P, and I. More importantly, we have grown large-sized and high quality

Black-P crystals *in situ* through this solid ternary inverse clathrate $Sn_{24}P_{22-x}I_8$ in a controlled manner, and clarified that ternary inverse clathrate $Sn_{24}P_{22-x}I_8$, not the commonly accepted vapor mineralizer, is critical for Black-P growth. We expect that the findings in this work could inspire the community to design the new growth strategies for Black-P, and eventually pave a practical way for future large and high quality phosphorene film growth on different substrates.

2. EXPERIMENTAL SECTION

2.1. Synthesis of Ternary Inverse Clathrate $Sn_{24}P_{22-x}I_8$. A stoichiometric mixture of red phosphorus lump (Alfa Aesar, 99.999%), tin shot (Alfa Aesar, 99.9999%), and iodine crystals (Alfa Aesar, 99.99%) was sealed under vacuum in a silica tube. The tube was slowly (0.5 °C/min) heated to 550 °C, annealed for 5 days, and then furnace-cooled to room temperature by turning of the power. After regrinding, the sample was heated at the same conditions for another 5 days. The $Sn_{24}P_{22-x}I_8$ ($x \sim 2.7$) is found to be stable and remains as a solid below 520-550 °C, and decomposes irreversibly above 600 °C. Previous single crystal studies have shown^{15,16} that the P vacancy in this material could be as high as 13% ($x \sim 2.7$), which is also consistent with our scanning electron microscopy (SEM) and energy-dispersive X-ray spectroscopy (EDX) analysis.

2.2. Synthesis of Black-P Crystals through Ternary Clathrate. An ~20 mg portion of $Sn_{24}P_{22-x}I_8$ powder is sealed in the silica tube under vacuum with 300 mg of Red-P loaded on top of the $Sn_{24}P_{22-x}I_8$ powder. The assembly was then put into the box furnace where the reactant end was at the center of the furnace, slowly heated up (0.5 °C/min) to 550 °C for 20 h where $Sn_{24}P_{22-x}I_8$ remained as a solid, and then rapidly cooled down (in 10–20 h) to 350 °C, followed by furnace quenching of the sample. This time, a layered square size of Black-P crystals formed at the exact place of the original ternary clathrate.

2.3. Synthesis of Black-P through Elements. Red-P lump (Alfa Aesar, 99.999%), tin shot (Alfa Aesar, 99.999%), and iodine crystals (Alfa Aesar, 99.99) were used. Different Sn:I ratios and different Red-P amounts were tested to further investigate the growth mechanism of Black-P. For a typical successful growth, the mixture of Red P:Sn:I₂ was sealed in silica ampules and was slowly heated up (0.5 °C/min) to

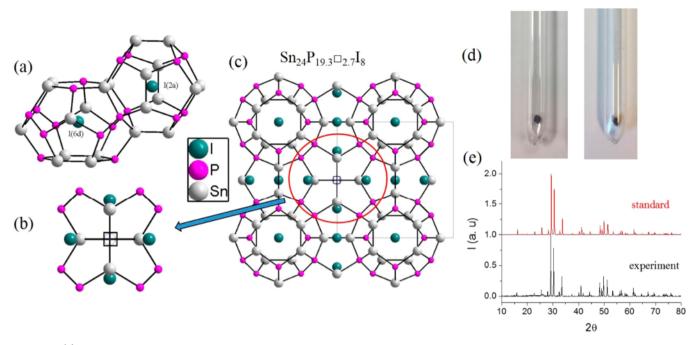


Figure 2. (a) Pentagonal dodecahedra and tetrakaidecahedron framework formed by Sn and P atoms in the clathrate $Sn_{24}P_{22-x}I_8$, where two different types of I atoms (2*a* and 6*d*) are located at the centers of each polyhedron. (b, c) The crystal structure of $Sn_{24}P_{22-x}I_8$, where the vacancy \Box caused by partially occupied P2 atom is highlighted. (d) Pictures of a $Sn_{24}P_{22-x}I_8$ pellet inside the reaction ampule before and after 550 °C, showing $Sn_{24}P_{22-x}I_8$ remains unchanged. (e) X-ray powder pattern of $Sn_{24}P_{22-x}I_8$ used for section 2.2.

the target temperature (600–620 °C) in a muffle furnace/tube. The assembly was kept at this temperature for 6 h, then gradually cooled down to lower temperature with different cooling rates for different tests. The growth was also stopped at different synthetic stages, with a series of photos taken immediately, to help better understand the roles of individual specimens and the growth mechanism.

2.4. Characterization of Black-P crystals. X-ray diffraction of one selected crystal was carried out at room temperature on a Rigaku SmartLab X-ray diffractometer equipped with Cu K α radiation. Raman spectroscopy measurement was carried out on a Thermo Scientific DXR Raman spectrometer. An FEI Helios Nano Lab 400 was used to for SEM studies of the morphology and composition of the Black-P crystals and ternary clathrate compound. High-resolution transmission electron microcopy (HRTEM, JEOL-2010F) images, selected area electron diffraction (SAED), and EDX mappings were executed on the sample of ultrasonically dispersed Black-P to characterize the structure and composition. Hall resistivity measurements were performed in a Quantum Design Physical Property Measurement System (PPMS) from 400 K down to 4 K through a five probe configuration on a freshly sliced Black-P thin crystal.

3. RESULTS AND DISCUSSION

Following the synthetic route in section 2.2, the as-grown Black-P crystals in the quartz ampule tube are shown in Figure 1a. One can clearly see that the Black-P crystals form at the site where the ternary clathrate $Sn_{24}P_{22-x}I_8$ originally resides, and no Black-P forms at the other end of the ampule (which has a slightly lower temperature due to the small temperature gradient from the center of the furnace to its edge), indicating the effective catalytic role of ternary clathrate $Sn_{24}P_{22-x}I_8$ for the Black-P growth. Both the optical image (Figure 1b) and SEM image (Figure 1c) indicate that these crystalline Black-P have a microribbons morphology with uniform thickness and width. From the side view, the well-aligned layered structure is clearly observed, and these crystals are easily exfoliated into a layered structure as shown in the SEM image (Figure 1d). The XRD pattern shows preferential orientation of (0k0) of the selected

crystals, and the peaks are well indexed with no peaks from the Sn₂₄P_{19.3}I₈ phase nor other impurities are observed. The Raman spectroscopy of the crystals shows sharp peaks at 362.4, 440.2, and 466.8 cm⁻¹, which match well with the Raman shifts attributed to vibrations of the crystalline lattice of Black-P: A_g^1 (out-of-plane mode), B_{2g} (in-plane mode), and A_g^2 (in-plane mode) phonon modes, respectively.¹⁷

Our direct synthesis of Black-P through the stable ternary Sn-P-I catalyst, rather than elemental components or gaseous SnI4 and SnI₂ species, provides an alternative method for Black-P synthesis under relatively lower synthetic temperature and pressure. From the available literature $^{5,8-14}$ where the starting materials and temperature profile were precisely given, the target temperature we used here is slightly lower (550 °C comparing with 590-650 °C), and more importantly, the pressure inside the ampule at the highest synthesis temperature is much lower. We have carried out several control experiments varying the amount of the starting materials and found out the minimum Red-P can be as low as 80 mg, which is equivalent to ~0.5 MPa, by assuming sublimed P_4 vapor at the highest synthesis temperature following the ideal gas law (confined quartz ampule space is 10 mm inner diameter \times 10 cm length). This pressure is much smaller than the previously reported value of ~3.5 MPa (~500 mg of Red-P sublimed at 650 $^\circ\mathrm{C}$ using a similar size of quartz ampule).¹³ This will be beneficial for future large-scale Black-P synthesis by other methods, e.g., chemical vapor deposition, since the high pressure caused by limited ampule space (which could potentially break the quartz ampule and cause safety issues if not handled properly) is now not a critical limiting factor any more.

Up to now, two phases of the ternary compounds consisting of Sn, P, and I are discovered.^{15,16,18} One is $Sn_{24}P_{22-x}I_8$ with a type-I clathrate structure^{17,19} and the other is SnIP with a double helices structure.¹⁸ Recently, Nilges et al. indicated that SnIP could decompose peritectically at 476 °C with formation of Sn₂₄P_{22-x}I₈ in a tightly enclosed space.¹⁸ Sn₂₄P_{22-x}I₈ was used in our research for the growth of Black-P in this work. The $Sn_{24}P_{22-x}I_8$ belongs to a well-known type-I clathrate struc-ture^{17,19} with a 3D inversed network composed by Sn and P atoms as host framework, and I as guest atoms (Figure 2a). The compound crystallizes in the cubic structure with space group $Pm\overline{3}n$ (#223), with five different atomic Wyckoff positions. It has vacancies within the host framework, as stressed by the formulation $Sn_{24}P_{19,3\square 2,7}I_{87}$ where \square denotes a vacancy. Sn atoms at the 24k position, and P1 atoms at the 16i position, together form two pentagonal dodecahedra. Other P2 atoms, forming the hexagonal faces of the 6 tetrakaidecahedrons, partially occupy the 6c atomic positions (1/4, 0, 1/2), which causes the vacancy structures in the framework (Figure 2b,c). Two of the 8 iodide atoms are located at the center of the 2 pentagonal dodecahedrons (I1 in the 2a position) and the 6 others at the center of the 6 slightly larger tetrakaidecahedrons (I2 at the 6d position). Previous lattice dynamics analysis¹⁶ has indicated that the host-guest interaction in this inverseclathrate compound is weak and that the dynamics of the guest atoms can be treated independently of that of the host framework. Our controlled experiments and differential scanning calorimetry (DSC) measurements show that this phase decomposes irreversibly to gaseous $P_4(g)$, $SnI_2(g)$, and liquid Sn(l) above 620 °C in the closed ampules. The ternary Sn₂₄P_{22-x}I₈ remains as a solid at the highest synthesis temperature 550 °C, as evidenced also in Figure 2d. The unique structure vacancies at the P sites in the framework of Sn₂₄P_{19.3□2.7}I₈ might hold the glue for its catalytic effect to grow Black-P crystals through the direct interaction of phosphorus vapor with this solid ternary precursor.

To investigate thoroughly the growth mechanism of Black-P crystals, we also grew Black-P crystals through the elemental Red-P, Sn, I2, and binary Sn-I compounds. We have varied the Sn:I ratio and the amount of Red-P used for the synthesis to investigate the necessity of chemicals and pressure required for the growth of Black-P. In addition, we also compared the synthetic attempts of using a tube furnace with hot/cold ends (temperature gradient > 100 °C, which promotes vapor transport reactions) and a box furnace with uniform temperature (temperature gradient < 5-10 °C from the center of furnace to the edge of the front door), which will be helpful for us to understand the possible growth mechanism as well. The growth processes were also stopped at different synthetic stages, with a series of photos taken immediately, and products analyzed afterward. Some crucial results are listed in Tables 1 and 2, from which we have found out: (1) Solely chemical additive of SnI2 or SnI4 does not work. Excess Sn besides the formation of SnI₂ is a crucial ingredient for a successful growth. A Sn: $I_2 > 2:1$ atomic ratio was found out to work the best

Table 1. Control Experiments for Formation of Black-PUsing a Slowly Cooling Rate

| no. | reactants | max. T (°C) | Black-P formation |
|-----|----------------------------------|-------------|-------------------|
| 1 | $RP + SnI_4$ | 600 | no |
| 2 | $RP + SnI_2$ | 600 | no |
| 3 | $RP + Sn + I_2 (Sn:I_2 \le 1:1)$ | 600 | no |
| 4 | $RP + Sn + SnI_2$ | 600 | yes |
| 5 | $RP + Sn + I_2 (Sn:I_2 > 1:1)$ | 600 | yes |
| 6 | $RP + Sn_{24}P_{19}I_8$ | 500-600 | yes |
| 7 | $RP + Sn_{24}P_{19}I_8$ | 480 | no |

(Table 1, Recipes 1-5). (2) Black-P crystals could be grown from both tube furnace and box furnace from elements. The temperature gradient (>50 °C) in tube furnaces is found out to be helpful to facilitate Black-P crystals growth (if grown from elements) but is not a necessity. (3) Black-P crystals form during the cooling process. Sn₂₄P_{22-x}I₈ forms first between 600 and 520 °C; then Black-P forms after the temperature decreases below 520 °C. (4) Black-P starts to form when the temperature is below 500 °C (500 and 480 °C) with evidence that a small segment of Black-P emerges at the end of the tube. However, at this stage, most of the P remains as $P_4(g)$, and is transferred to Red-P (coated inside the tube) and White-P droplets on the quartz wall if reaction is quenched. (5) The formation of Black-P is nearly completed at the temperature below 420 °C with evidence as following: (a) the quartz tube is clean clear, indicating nearly no $P_4(g)$ transfer to Red-P or White-P upon quenching; (b) the crystals' shapes and morphology are nearly identical for the two batches quenched at 420 and 350 °C (meaning formation is completed at the T \sim 420 °C). Therefore, it is fair to say that the formation of Black-P is a rapid growth progress between 420 and 520 °C.

On the basis of the aforementioned findings, we could conclude with a likely Black-P crystal growth mechanism where the roles of individual elements at different temperature stages are identified. In the growth of Black-P with elements or Sn-I binary compounds, the initial materials of Sn, I2, and Red-P are readily reacted/vaporized to form gaseous SnI₂, and P₄ upon heating from room temperature to 600 °C. The excess of Sn remains as a liquid at this stage, but could be transported to the cold side (if any) through vapor transport reactions (Sn + $I_2 \rightarrow$ SnI_2). Upon cooling, from 600 to ~500 °C, these gaseous species react with each other and form the solid ternary Sn₂₄P_{22-x}I₈ phase first, and the excess of P element still remains as the P4 vapor. During this stage, the chemical vapor transport reaction does help with the formation of the solid phase of Sn₂₄P_{22-x}I₈, but no Black-P crystal has formed yet. Upon further cooling below ~520 °C, the P₄ vapor steadily transfers to Black-P crystals through a likely vapor-solid-solid (VSS) mechanism $^{20\mathchar`-22}$ via $Sn_{24}P_xI_8$ phase. During this stage, the Sn₂₄P_{22-x}I₈ phase not only provides the nucleation center for Black-P crystals but also acts as a media to transport elemental P for the continuous Black-P crystal growth. The host-guest and P-site vacancy structure features in the clathrate Sn₂₄P_{22-x}I₈ phase allow chemical reactions of P4 vapor with the host structure where the excess P then could diffuse out from the host structure (therefore suppress the energy barrier) to form Black-P crystals. The whole reaction happens rather fast (less than 12 h) and stopped at the temperature below 350 °C.

It is worthwhile to note that vapor-phase mechanisms including vapor-liquid-solid (VLS) and vapor-solid-solid (VSS) are primary growth modes for nanowires and nano-tubes,²³⁻²⁸ where vapor is the precursor of the final product (solid), and catalyst is a nanodroplet (liquid) or nanoparticle (solid). For the VSS mode, the solid catalyst is either an alloy or a compound consisting of foreign and final product elements. In the growth of Black-P by $Sn_{24}P_{22-x}I_8$ catalyst, VSS is the possible growth mechanism with the evidence: (1) all as-grown Black-P belts attach on $Sn_{24}P_{22-x}I_8$ particles; (2) in the growth temperature of Black-P, $Sn_{24}P_{22-x}I_8$ is a solid; and (3) in the lattice of $Sn_{24}P_{22-x}I_8$, P vacancies can vary from X1% to X2%, depending on the partial pressure of P₄. The vacancies in a solid may greatly enhance the diffusion of the certain atoms in it.²⁹

Table 2. Control Experiments for Formation of Black-P Crystal at Different Quenching Temperatures after Slowing Cooling from 600 $^{\circ}C^{a}$

| | 600 °C | 550 °C | 520 °C | 500 °C | 480 °C | 420 °C | 350 °C | |
|---|---------|------------------|------------------|---------|---------|--------|--------|--|
| Black-P formation | no | no | no | yes | yes | yes | yes | |
| products | RP + WP | Sn-P-I + RP + WP | Sn-P-I + RP + WP | BP + RP | BP + RP | BP | BP | |
| "RP: Red-P, WP: White-P, and BP: Black-P. | | | | | | | | |

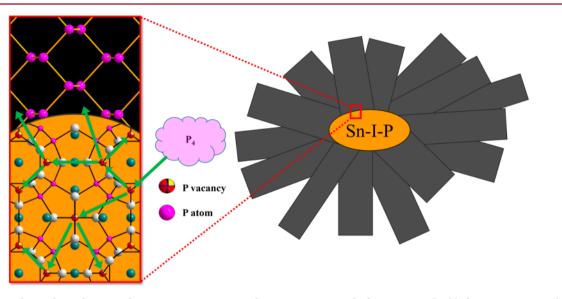


Figure 3. Proposed growth mechanism. The orange part represents the ternary compound of $Sn_{24}P_{22-x}I_8$; the black part represents Black-P; the purple dots represent P atoms; the colorful dots represent P vacancies; the green dots represent I atoms; and gray dots represent Sn atoms. The green arrows indicate the possible diffusion path of P atoms with the assistance of P vacancies.

the VSS mode, as shown in Figure 3. When temperature is lower than 520 °C, $Sn_{24}P_{22-x}I_8$ is stable; then P_4 can decompose at the surface of $Sn_{24}P_{22-x}I_8$ and P atoms diffuse into $Sn_{24}P_xI_8$. When the P concentration is high enough in $Sn_{24}P_{22-x}I_8$, P begins to segregate at some locations on the surface of $Sn_{24}P_{22-x}I_8$ as Black-P, the most stable phase for phosphorus in thermodynamics. With time going on, the Black-P P grows longer. Different from VLS, in general, the nanowires grown under VSS have uniform diameter from tip to bottom, since the size of catalyst in solid is more stable. In this work, the uniform width of the Black-P belt is also uniform, which supports the VSS hypothesis.

Finally, we examined the temperature dependence of the carrier mobility through Hall measurements. A six wire method was utilized to simultaneously measure the resistivity and Hall coefficient of freshly cleaved bulk Black-P crystals. The inset of Figure 4 schematically shows the contact of 6 wires, where contact leads of 1, 2, 5, 6 were used to determine the electric resistivity of the sample and contact leads of 1, 3, 4, 6 were used for the Hall measurement. The contribution of the transverse resistance Rxx, which was induced due to any possible misalignment of the two Hall probes, is further eliminated through $R_{xy}(H) = (R_{xy}(+H) - R_{xy}(-H))/2$, since R_{xx} will not change when the direction of applied magnetic field is changed to the opposite direction. Through this method, we can get the actual Hall resistance of the bulk sample. The positive Hall coefficient indicates the charge carriers are mainly p-type in our bulk Black-P samples. The derived bulk Hall mobility shows a broad peak around 250 K, with the room temperature mobility μ is near 350 cm²/V·s as shown in Figure 4. The obtained mobility value is higher than most of the reported values of bulk crystals,³⁰ and is even comparable with some of reported values

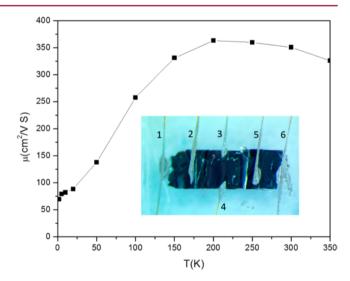


Figure 4. Hall mobility of a Black-P belt with temperature along a randomly chosen direction.

with few layers and monolayer of Black-P.^{31–33} Given the unavoidable microcracks on the surface during cleavage (which could be clearly observed in the figure inset), we believe that the actual value of mobility could be even higher, which further supports the high quality of the Black-P crystals synthesized through this new method.

In conclusion, we have synthesized high quality Black-P crystals *in situ* using ternary clathrate $Sn_{24}P_xI_8$ as the catalyst. X-ray diffraction, SEM, Raman, and TEM studies show high quality of grown crystals. Through detail investigation of the growth mechanism using different synthesis routes, we have

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found out the growth temperature and pressure range for Black-P crystal growth, identified the role of individual chemical additives in favor of the formation of Black-P, and suggested that the VSS, rather than the commonly accepted vapor transport reaction, is a likely growth model. The P vacancy in the framework of ternary clathrate is apparently crucial for the *in situ* growth of Black-P at the clathrate site. The Hall measurement shows high mobility in the as-grown bulk crystals.

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Notes

The authors declare no competing financial interest.

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